## **Amendments to the Claims:**

This listing of claims will replace all prior versions, and listings, of claims in the application:

## **Listing of Claims:**

- 1-4. (Cancelled).
- 5. (Currently Amended) A method for assembling an integrated circuit package, comprising:

applying a thermaln epoxy to a top surface of an integrated circuit;

placing a thermal element adjacent to the thermal epoxy; and,

curing the thermal epoxy with energy at a microwave frequency; and

applying an encapsulant differing in composition from the thermal epoxy after curing of the thermal epoxy.

- 6. (Previously Presented) The method of claim 5, further comprising mounting the integrated circuit to a substrate.
- 7. (Previously Presented) The method of claim 6, further comprising attaching a solder ball to the substrate.
- 8. (Currently Amended) The method of claim <u>65</u>, <u>further comprising wherein the</u> <u>applying of the encapsulant comprises molding an the encapsulant onto the substrate and the integrated circuit.</u>
- 9. (Currently Amended) A method for assembling an integrated circuit package, comprising:

applying an thermal epoxy to a thermal element, the thermal epoxy being an epoxy resin contain a thermally conductive filler;

placing the <u>thermal</u> epoxy and the thermal element onto <u>a top surface of</u> an integrated circuit; <del>and,</del>

curing the <u>thermal</u> epoxy with energy at a microwave frequency; <u>and</u>

<u>applying an encapsulant after curing of the thermal epoxy, the encapsulant differing in</u>

composition from the thermal epoxy and forming the integrated circuit package.

- 10. (Previously Presented) The method of claim 9, further comprising mounting the integrated circuit to a substrate.
- 11. (Previously Presented) The method of claim 10, further comprising attaching a solder ball to the substrate.
- 12. (Currently Amended) The method of claim 109, wherein the applying of the encapsulant further-comprisesing molding anthe encapsulant onto the substrate and the integrated circuit.
- 13. (Original) The method of claim 5, wherein said thermal element is a heat spreader.
  - 14. (Cancelled).
- 15. (Currently Amended) The method of claim 145, wherein said thermally conductive filler includes carbon particles.
- 16. (Original) The method of claim 5, wherein said placing of said thermal element includes attaching said thermal element to said epoxy.
- 17. (Currently Amended) The method of claim 5, wherein said curing of the epoxy includes

selecting the microwave frequency to cure the <u>thermal</u> epoxy without damaging the integrated circuit or heating other components within the integrated circuit package; and

generating energy at the microwave frequency by a microwave generator directed toward the <u>thermal</u> epoxy.

- 18. (Currently Amended) The method of claim 9, wherein prior to applying said thermal epoxy to the thermal element, the method further comprises providing a thermally conductive filler to a resin to form said epoxy.
- 19. (Currently Amended) The method of claim 9 further comprising baking a substrate into which the integrated circuit is to be mounted before curing the <u>thermal</u> epoxy.
- 20. (Currently Amended) The method of claim 9, wherein said curing of the <u>thermal</u> epoxy includes

selecting the microwave frequency to cure the epoxy without damaging the integrated circuit or heating other components within the integrated circuit package; and

generating energy at the microwave frequency by a microwave generator directed toward the <u>thermal</u> epoxy.

- 21. (Currently Amended) The method of claim 6, wherein prior to curing the <u>thermal</u> epoxy, the method further comprising baking a substrate onto which the integrated circuit is to be mounted.
  - 22. (Currently Amended) A method comprising:

applying an thermal epoxy to a thermal element;

mounting the thermal element on <u>a top surface of</u> an integrated circuit placed in an integrated circuit package <u>mounted on a substrate</u>, the <u>thermal</u> epoxy interposed between the thermal element and the integrated circuit; <del>and</del>

baking the substrate along with the integrated circuit package, the thermal element and the thermal epoxy;

curing the <u>thermal</u> epoxy by radiating energy at a microwave frequency toward the <u>thermal</u> epoxy to cure the <u>thermal</u> epoxy without damaging the integrated circuit or heating other components of the integrated circuit package.

23. (Previously Presented) The method of claim 22, wherein the epoxy is a thermal conductive filler with carbon particles.

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